

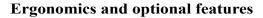
Cindbest CH Series

200mm - 300mmManual Probe Station System

FEATURES / BENEFITS

Usefulness

- ▶ Applications: Suitable for a variety of wafer measurement applications, wafer level reliabilit (WLR), failure analysis (FA), integrated circuit engineering, micro-electromechanical systems (MEMS) and high power (HP)
- ▶ Test IV curve, CV curve, LIV curve, RF test, high voltage and high current test



- Adjustable needle seat platform quickly lifts and lowers for easy separation of sample and probe
- Chuck rotation lock
- Header platform accepts DC/RF positioners (magnetic or vacuum mounted)
- ▶ Available in a variety of configurations, including various chuck options, DC/RF/high voltage 1~10KV, micro positioners, microscopes, cameras, PCB holders, etc.



Platform configuration parameters

	Model	CH-8	CH-12	
	Chuck Size	8 inches	12 inches	
	Sample stage pull-out	Travel: 110mm	Stroke: 150mm	
	Sample stage rotation	Can rotate 360°, can be fine-tu	ned by 15°, with an accuracy of	
	Sample stage rotation	0.1°, and has an angle locking device		
Platform	Sample fixation	Vacuum adsorption, Central adsorption hole, Multi-circle		
Platioiiii	method	adsorption ring		
	Sample stage Z axis lifting	Can be raised or lowered 8mm		
	X-Y travel range	8 inches*8 inches 12 inches*12 inch		
	X-Y air floating travel	360° air-floating movement	for quick sample positioning	



	XY movement accuracy	1um		
	Needle Seat Platform	Can quickly raise and lower by 5mm and fine-tune by 25mm		
	Back electrode test	The sample stage is electrically independent and suspended, and the 4mm jack can be connected to the back electrode (optional)		
Microscope	Microscope fixing method	Gantry with X-Y fine adjustment, moving range 2" x 2"		
travel module	Mobile itinerary	2 inches * 2 inches		



Microscopes - Selection Guide

High Power Microscope - Metallography

----Used for spot testing of small size pad devices and loading laser

Zoom	1X~2X
Eyepiece	10Xor 20XOptional
Z-axis handwheel	
focusing range	50.8mm
CMount	0.5X
Objective	5/10/20/50/100XOptional
Manual nose wheel	4 holes
Maximum	
magnification	2000X or 4000X
Light source	150WHigh power white light source



Motic PSM-1000

Low Power Microscope - Stereo

----Used forLarge size padDevicesSpot Test

Zoom	0.8X~5X
Eyepiece	20X
Z-axis handwheel	
focusing range	50.8mm
CMount	0.4X
Auxiliary objective lens	
can be loaded	2X
Minimum resolution	2um
Maximum	
magnification	100X or 200X
Light source	ledRing light



Microscope - Monocular Metallography

----The standard lens can be used for spot measurement of large-size pads, and it can be used for spot measurement of small-size pads after adding a metallographic objective lens



Continuous zoom ratio	0.75 - 5X
Standard objective lens	1X
CMount	1X
Working distance	82mm
Additional objective	
lens	5/10/20/50XOptional
MinimumResolution	2um
Maximum	Zoom * Camera * Objective Lens * Display
magnification	= Magnification
Light source	Coaxial light source



Cindbest 0745

Probe Holders - Selection Guide

Fixing methods: magnetic switch adsorption / vacuum adsorption optional

▶ CB-40-T movement accuracy 2um Travel range XYZ: 12mm Economical price, small size, ideal for pad/large contact probing



▶ CB-100 movement accuracy 0.7um XYZ linear motion, suitable for probing as small as 1 micron Travel range XYZ: 12mm DC, RF, fiber optic switchable fixed



CB-200 movement accuracy 0.5um, XYZ linear motion, suitable for probing as small as 1 micron Travel range XYZ: 20mm DC, RF, fiber optic switchable fixed



CB-200



RF Fixed

Fiber Fixing

Probe Fixtures - Selection Guide



	Coaxial clamp	Three-axis fixture	Kelvin clamp
Maximum voltage	700 V	1500 V	250V
Maximum voltage	1A	10A	1A
Temperature range	-60 °C to 300 °C	-60 °C to 300 °C	-60 °C to 300 °C
Leakage Current	< 10pA	<100fA	< 20fA
Connectors	BNC(M)	Standard Triax(M)	SSMC
Probe fixing method	Spring fixation or tubular fixation	Spring fixation or tubular fixation	Screw locking
Probe tip material	Tungsten	Tungsten	Tungsten
Probe tip size	0.5 μm – 25 μm	0.5 μm - 25 μm	0.5 μm – 25 μm
Cables	1.5m long coaxial cable	1.8m long three-axis	1m long three-axis line

High Voltage / High Current Probes - Selection Guide

High voltage

	O		
Model	HV-3KV	HV-5KV	HV-10KV
Maximum voltage	3KV	5KV	10KV
Maximum current	2 A Pulsed	5 A Pulsed	3 A Pulsed
Temperature range	-60℃ to 200℃	-60℃ to 200℃	-60℃ to 200℃
Leakage Current	< 300fA @ 3000V	< 100PA @ 5000V	< 100nA @10000V
Connector Type	HV Triaxial/BNC Coaxial/Banana	SHV	UHV
Replaceable probe	Yes	Yes	Yes
Probe material	W	W	W



High current

High Current Probe Fixture



High Current Replacement Probe - Multi-Finger Type



Model	HC-200	HCT-200
Maximum voltage	/	500V
Maximum current	/	20A DC/200A Pulsed
Leakage Current	/	N/A
Connector Type	/	HV Banana
Replaceable tips	1	Yes
Probe material	/	BeCu or W
Number of needle	1	8
tips	1	o

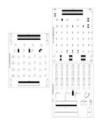
RF Probes - Selection Guide



	40A	50A	67A	110H
Frequency	DC-40GHz	DC-50GHz	DC-67GHz	DC-110GHz
Connectors	2.92mm	2.4mm	1.85mm	1.0mm
Pin structure	GS/SG/GSG	GS/SG/GSG	GS/SG/GSG	GS/SG/GSG
Spacing range	25μ - 2540μ	25μ - 1250μ	25μ - 1250μ	525μ - 1250μ
Insertion loss	<.8db	<1.0db	<1.1db	<1.5db
Return loss	> 18db	>18db	>14db	>15db



Calibration Substrate Selection Guide



Calibration Substrate	Pad Size (microns)	Calibration Types Supported	Footprint	Pitch Range Recommended (microns)	Pitch Range Acceptable (microns)
CS-5	50 x 50	SOLT, LRL, LRM	GSG	75 - 250	75 -250
CS-9	100 x 100	SOLT, LRL, LRM	GSG	250 - 600	150 - 600
CS-10	150 x 150	SOLT, LRM	GSG	600 - 1250	225 - 1250
CS-18	300 x 300	SOLT, LRM	GSG	1250 - 2540	500 - 2540
CS-8	50 x 50 100 x 100 150 x 150	SOLT, LRM	GS, SG	50 - 200	50 -300
CS-14	100 x 100	SOLT, LRM	GS, SG	200 - 400	150 - 600
CS-11	150 x 150	SOLT, LRM	GS, SG	400 - 1250	175 - 1250
CS-17	300 x 300	SOLT, LRM	GS, SG	750 - 2540	450 - 2540

RF Cables

	40GHz	50GHz	67GHz	110GHz
Frequency Range	DC - 40GHz	DC - 50GHz	DC - 67GHz	DC - 110GHz
Length	120cm	120cm	120cm	15cm
Connectors	2.92M – 2.92M	2.4M – 2.4M	1.85 M - 1.85 M	1.0M - 1.0M

^{*} Contact Factory

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Chuck options

	Normal temperature chuck	Normal high temperature chuck	Normally high temperature back electrode chuck
Diameter	8 inches / 12 inches	8 inches / 12 inches	8 inches / 12 inches
Material	Stainless steel	Nickel-plated aluminum	Copper gold plated
Adsorption method	Annular adsorption hole vacuum adsorption	Annular adsorption hole vacuum adsorption	Annular adsorption hole vacuum adsorption



Adsorption ring	4 laps	4 laps	4 laps
Adsorption pore size	1mm*	1mm*	1mm*
Temperature range	/	RT-200°C (can be upgraded to 300, 400, 500°C)	RT-200°C (upgradable to 300°C)
Temperature resolution	/	0.1°C	0.1°C
Temperature control accuracy	/	0.1°C	0.1°C
Temperature stability	/	±1°C	±1°C
Applicability	Tested at room temperature	Tested in high temperature environment	Under high temperature environment and back electrode pressure test is required

^{*1}mm is the standard aperture. If necessary, it can be changed to a smaller aperture adsorption hole







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Chuck options

	Room temperature coaxial chuck	Room temperature three-axis chuck	Room to high temperature coaxial chuck	Room to high temperature three-axis chuck	
Diameter	8 inches / 12 inches	8 inches / 12 inches	8 inches / 12 inches	8 inches / 12 inches	
Material	Aluminum alloy nickel or gold plated, stainless steel*	Aluminum alloy nickel or gold plated, stainless steel	Aluminum alloy nickel or gold plated, stainless steel	Aluminum alloy nickel or gold plated, stainless steel	
Adsorption method	Annular/Porous*	Annular/Porous*	Annular/Porous*	Annular/Porous*	
Adsorption ring	8 inches: 15, 40, 70, 105, 140, 165, 190 mm 12 inches: 15, 40, 70, 105, 140, 165, 190, 230, 260, 290 mm				
Adsorption pore size	0.5mm*	0.5mm*	0.5mm*	0.5mm*	
Temperature range	1	1	RT-200°C (Upgradable to 300°C)	RT-200°C (Upgradable to 300°C)	
Temperature resolution	1	1	0.1°C	0.1°C	
Temperature control accuracy		/	0.1°C	0.1°C	
Temperature stability	/	/	±1°C	±1°C	
Leakage accuracy	≤50PA@±5V/25°C	≤100fA @ ± 5V/25°C	≤50PA@±5V/25°C	≤100fA @ ± 5V/25°C	
Heating and cooling rate	/	/	25°C-200°C ≤ 20min@8 inches 200°C-300°C ≤ 25min@8 inches	25°C-200°C≤30min@8 inches 200°C-300°C≤35min@8 inches	
applicability	Tested at room temperature	Tested at room temperature	High temperature and high	High temperature and high temperature	



temperature back electrode test

back electrode test

- *0.5mm is the standard aperture of the porous adsorption chuck, which can be customized if necessary
- *Porous adsorption is suitable for thin sheets ≤200um thick
- *About chuck material: Gold plating is recommended for high-power device testing, gold plating or nickel plating is recommended for back electrode testing, and stainless steel is generally used



TEC Refrigeration Water Tank

Using TEC electric cooling method, the water temperature can be reduced to 0°C

- ▶ Heat dissipation 10W/°C
- ▶ Temperature display, can intuitively display water temperature
- ▶ Effectively protect machine safety
- Water tank capacity: 0.5L
- ▶ Pump flow rate: 1L/min
- Lift: 5M









PD laser machine



Used for metal cutting inside the chip, Mark point marking

- ▶ Three-band laser
- Wavelengths include 1064nm,

532nm, 355nm

Repetition frequency: internal trigger

1Hz; external trigger is possible

Laser energy: 1mJ

▶ Light scattered eastward: 5~6mrad

Laser pulse width:--10 ns

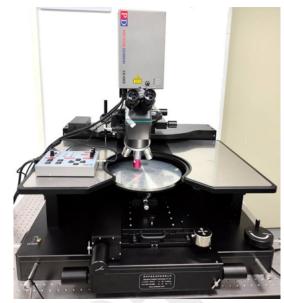
Cooling method: air cooling

Built-in CCD camera

Minimum cutting size: 2um

Warranty: One year

▶ Lifespan:>3 million times









System Options

Accessories

Shielding box (CB-6)

The Probe Station light-tight, electrically shielded enclosure is idea

- Low leakage measurement
- ▶ High Power Measurement Thermal Measurement
- ▶ Light sensitivity measurement

Door and panel interlock options are often used for high pressure



CB-6

safety

Integrated shielding box

- Lift-up opening method
- ▶ Built-in air-floating shock-proof table
- Legs with casters





- ▶ Compatible with probe stations within CH-8
- ▶ Effectively protect the operator's safety during high voltage and high current testing (infrared light curtain can be installed)
- ▶ Effectively shield signal interference and leakage, effectively isolate external vibration, and improve test accuracy
- Contains 4 triaxial female to triaxial female connectors
- There are adapter mounting plates on the left and right sides, each with 8 holes, and a concealed cable outlet at the rear
- Dimensions: 1200*900*1800
- ▶ Inner dimensions: 1000x780x950 (excluding the bottom cabinet)

Probe Card Fixture

Used forfixedProbe Card



Silent oil-free vacuum pump

- It can operate 24 hours a day to provide vacuum adsorption for the stage;
- Air flow: 7L/min, silent and oil-free
- Vacuum degree: -250mm/Hg;
- > Size: 98mm*58mm*80mm,
- ▶ Weight: 0.7kg;
- ▶ Power requirement: 220V/50Hz.



VP0125

Optical anti-vibration table

	Damping anti-vibration table	Air floating shockproof table
Model	CBPT Series	CBDT Series
Size	Customizable	Customizable
Natural frequency	6Hz (horizontal) 8Hz (vertical)	1.5Hz (horizontal) 2Hz (vertical)
Countertop Material	Stainless steel SUS430	Stainless steel SUS430
Screw hole	M6	M6



CBP



Screw hole pitch	25mm×25mm	25mm×25mm		
Table surface	≤0.03mm/m2	≤0.03mm/m2		
flatness				
Isolation	Damping	Air flotation		
method				
Air compressor				
Pressure	N/A	0.7mpa		
Voltage	N/A	220V-50Hz		
frequency				
Power	N/A	350W		
Noise	N/A	<40db		
Exhaust	N/A	20L/min		
volume				



CBDT



System Dimensions - Optional

Vibration-Proof Table

Model CH-8 CH-12 Size 750W*820D*650H 925W*947D*815H Weight About 103 kg About 170 kg

Warranty

- ▶ Standard warranty 12 months*
- ▶ For extended warranty and service contracts: please contact Shenzhen Sendongbao Technology Co., Ltd. for more information
- * For more details please refer to Cindbest Terms and Conditions of Sale.



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